YOUNGJIN KIM

PhD Candidate

Seoul National University, Seoul, South Korea

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EDUCATION

B.S. Electrical and Computer Engineering

Seoul National University, Seoul, Republic of Korea

Advisor: Byung Gook Park (deceased)

M.S. - Ph.D. Electrical and Computer Engineering 2019.3 – 2025. 2 (expected)

Seoul National University, Seoul, Republic of Korea

Former advisor: Byoungho Lee (deceased)

Current advisor: Yoonchan Jeong (yoonchan@snu.ac.kr)

PROFESSIONAL EXPERIENCE

Visiting Researcher Stanford University, CA, USA

2023. 12 - 2024. 2

2012.3 - 2019.2

- Professor: Mark Brongersma, Department of Materials Science and Engineering

Research Scientist Intern Meta Reality Labs, Washington, USA

2024. 6 - 2024. 10

- Department: Display & Optics

RESEARCH EXPERIENCE

- Metasurfaces / Nano-optics
 - Physical understanding of nanostructures' optical response
 - Metasurfaces / Nano-optics design using near-field and far-field simulations
 - Hands-on nanofabrication using lithography-techniques
- Waveguide system design
 - Waveguide-type folded metasurface system design using ray-tracing or wave-optics simulations
 - Hands-on wafer double-side nanofabrication using lithography-techniques
- Data-driven optimization of optical systems through machine-learning framework
 - Joint optimization of metasurface and spatial light modulator (SLM) phase profiles
 - End-to-end optimization of metalens imaging system (Hardware + Software co-design)
 - Metasurface proxy model design for fully differentiable optimization framework
- Inverse design of metasurface through optical simulation algorithms
 - Metasurface blazed grating optimization through rigorous coupled-wave analysis using automatic differentiation

Application to imaging system / 3D holographic display / optical neural network

SKILLS

Numerical Optical near-field simulations: simulations RCWA (Python, Pytorch), FEM (

RCWA (Python, Pytorch), FEM (COMSOL Multiphysics), FDTD (Lumerical)

Optical far-field simulations:

Ray-optic simulation (Zemax), Wave-optic simulation (MATLAB, Python, Pytorch)

Computational optics design:

Data-driven optimization through machine-learning framework (Pytorch),

Inverse design of periodic nanostructures using automatic-differentiation (Pytorch)

Programming languages & tools:

MATLAB, Python (Pytorch), ZPL (for Zemax)

Experimental experiences

Optical microscopy, Photography, Holographic display with spatial light

modulator, Laser/LED-based experiments

Device fabrication Nanofabrication:

Focused ion beam (FIB) milling, Electron beam lithography, Photolithography (Aligner, Maskless lithography), Electron beam evaporator, Plasma-enhanced

chemical vapor deposition (PECVD), Reactive ion etching (RIE)

Measurement:

Scanning electron microscope (SEM), Ellipsometry

Languages Korean (Native) / English (Fluent)

RESEARCH EXPERIENCE - Projects

Metalens planar optic system for ultra-slim camera module

Researcher, Samsung Science & Technology Foundation Jun. 2020 – July. 2023

Improvement of μLED optical characteristics using metasurface technology.

Researcher, Samsung Display March. 2021 – Feb. 2023

Research for integrated meta-photonics system and its application to mobile real-time 3D imaging

Researcher, National Research Foundation of Korea

Mar. 2020 - November. 2022

Development of virtual reality technology using metasurface optics

Researcher, Samsung Display March. 2020 – Feb. 2021

HONOR AND AWARDS

Seoul National University Joint International Research Grant

Seoul National University, 2023.

Silver Prize, Samsung Display Industry-Academia Technical Paper Awards

- Samsung Display, 2023.
- Scholarship of Foundation for SNU ECE Kim Jung Sik Fund Seoul National University, 2021.
- Best Poster Paper Awards

Optics and Photonics Congress, Jeju, South Korea, 2021.

JOURNAL PUBLICATIONS

First Author (2)

† : equal contribution

- 1. Y. Kim, G. -Y. Lee, J. Sung, J. Jang, and B. Lee, "Spiral Metalens for Phase Contrast Imaging," Advanced Functional Materials, vol. 32, no. 5, pp. 2106050, 2022.
- 2. S. -W. Nam[†], Y. Kim[†], D. Kim, and Y. Jeong, "<u>Depolarized Holography with Polarization-multiplexing</u> Metasurface," ACM Transactions on Graphics (SIGGRAPH Asia), vol. 42, no. 6, article 200, 2023.

JOURNAL PUBLICATIONS

Co-Author (3)

- S.-J. Kim, C. Kim, Y. Kim, J. Jeong, S. Choi, W. Han, J. Kim, and B. Lee, "<u>Dielectric metalens: properties</u> and three-dimensional imaging applications," Sensors, vol. 21, no. 13, pp. 4584, 2021.
- J. Jang, G. -Y. Lee, Y. Kim, C. Kim, Y. Jeong, and B. Lee, "<u>Dispersion-Engineered Metasurface Doublet Design for Broadband and Wide-Angle Operation in the Visible Range</u>," IEEE Photonics Journal, vol. 15, no. 4, pp. 1-9, 2023.
- 3. C. Kim, J. Hong, J. Jang, G. -Y. Lee, Y. Kim, Y. Jeong, and B. Lee, "Freeform Metasurface Color Router for Deep Sub-micron Pixel Image Sensors," Science Advances, vol. 10, no. 22, pp. eadn9000, 2024.

CONFERENCES First Author (5)

- 1. Y. Kim, C. Kim, B. Lee, Y. Jeong, and B. Lee, "Meta-optic Miniaturized Telephoto Lens System," High Contrast Metastructures XII, SPIE Photonics West 2023, San Francisco, USA, paper 12432-32, Feb. 2023. (Oral presentation)
- 2. **Y. Kim,** C. Kim, and B. Lee, "Phase contrast imaging with multiwavelength achromatic spiral metalens," OSA Optical Design and Fabrication Congress, Virtual Conference, paper FW4C.3, Jun. 2021. **(Oral presentation)**
- 3. Y. Kim, J. Hong, and B. Lee, "Edge detection metalens with additional spiral phase profiles," The 20th International Meeting on Information Display (IMID 2020), Virtual Conference, paper 04-10-1232, Aug. 2020. (Oral presentation)
- 4. **Y. Kim,** C. Kim, and B. Lee, "Single-layer edge detecting metalens with combining hyperbolic and spiral phase profiles," The 14th Pacific Rim Conference on Lasers and Electro-Optics (CLEO PR 2020), Virtual Conference, paper P5-7, Aug. 2020.
- 5. Y. J. Kim, J. Hong, J. Sung, and B. Lee, "Transmission-Type Color Filters with Silicon Mie Resonators using Guided-Mode-Resonance," OSA Frontiers in Optics + Laser Science APS/DLS, Washington D.C., USA, paper JW4A.74, Sep. 2019.